



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2814  
Examiner: Long PHAM

## In Re PATENT APPLICATION Of:

Applicants	:	Jiro MATSUMOTO	)	
Appln. No.	:	10/727,662	)	
Filed	:	December 5, 2003	)	
For	:	SEALING APPARATUS FOR SEMICONDUCTOR WAFER, MOLD OF SEALING APPARATUS AND SEMICONDUCTOR WAFER	)	<u>AMENDMENT</u> <u>AFTER FINAL</u> <u>ACTION</u>
Attorney Ref.: F00ED0150-DIV				)

July 27, 2007

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Final Office Action mailed February 27, 2007,  
which has been extended to expire on May 27, 2004 by Petition for two-month  
Extension of Time filed herewith, please amend the above-identified application as  
follows: